NEL-SYSTEM

Wafer protection tape remover HR8500III TW-UV OPERATION MANUAL

NITTO DENKO NITTO SEIKI

Overview



WARNING



Read this instruction manual carefully and have a complete understanding of the contents before use.

Observe all warnings and cautions in this manual.

Failures to observe warnings and cautions could cause of serious injuries to human body and damage/performance decrement of the equipment.

Keep this instruction manual so that you can use it at anytime.

This manual consists of below:

Vol. 1 Installation manual

Vol. 2 Operation manual

Vol. 3 Maintenance manual

This manual is Vol. 2 Operation manual to operate the equipment correctly and safely by the operators.

The operators must follow the rules.

- The operators are allowed to do works shown in "Vol.2 Operation manual".
- Only authorized persons are allowed to do the works shown in "Vol. 1 Installation manual" and "Vol.3 Maintenance manual".
- The operators are not allowed to have use of any tools, such as screwdrivers and wrenches.
- The operators are not allowed to have keys for lockout and override the safety interlock.

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